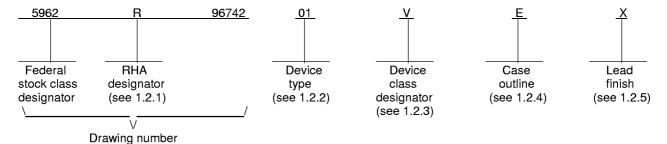
									REVISI	ONS										
LTR					[DESCF	RIPTIO		12 7101				D/	ATE (Y	R-MO-[DA)		APPF	ROVED	
А	Char	naes in	accord	lance w	ith NO	R 5962	-B104-	.98 - i	rrn					•	05-11				ONNIN	
В				ements						rrn					12-09					
											rrn									
C				1.5 and											04-19					
D	appe	ndix A.	- ro	2. Make		ges to 1	1.2.2, 1	.5, tabl	e I, figu	re 1, ar	nd				11-24				ИІИИС	
Е	Made	e chanç	ges to f	igure 3	rrp									00-0	01-03			R. M	ONNIN	
REV		Γ	I			T	Γ	ı	T	Ι		Ι	ı		ı		T	T		
REV SHEET																				
REV SHEET REV	E	E	E	E	E	E	E	E	E	E	E	E	E							
SHEET	E 15	E 16	E 17	E 18	E 19	E 20	E 21	E 22	E 23	E 24	E 25	E 26	E 27							
SHEET REV					19			-	 	1			 	E	E	E	E	E	E	E
SHEET REV SHEET REV STATUS OF SHEETS				18 REV SHE	19 ET	20	21	22	23	24	25	26	27	E 8	E 9	E 10	E 11	E 12	E 13	E 14
SHEET REV SHEET REV STATUS OF SHEETS PMIC N/A STAN	15 NDAF	16		18 REV SHE PREI SAN	19	20 BY ROONE	21 E 1	22 E	23 E	24 E	25 E 5	26 E 6	27 E 7	8 UPPL		10	11 COL	12 LUMB	13	
SHEET REV SHEET REV STATUS OF SHEETS PMIC N/A STAN	NDAF OCIRO WIN IG IS A SE BY A RTMEN ICIES O	TO CUIT G VAILA ALL ITS OF THE	17	18 REV SHE PREI SAN CHE SAN	TET PARED NDRA F CKED NDRA F	20 BY ROONE BY ROONE A. FRY	21 E 1	22 E 2	23 E	E 4 MIC HAI	25 E 5 DI	26 E 6	E 7 SE SI COL	UPPL UMBI	9 .Y CE	NTEF HIO	ATIO	LUMB 6	13 US	
SHEET REV SHEET REV STATUS OF SHEETS PMIC N/A STAN MICRO DRA THIS DRAWIN FOR US DEPAR AND AGEN DEPARTMEN	NDAF OCIRO WIN IG IS A SE BY A RTMEN ICIES O	TAD CUIT G VAILAITS OF THE DEFEN	17	18 REV SHE PREI SAN CHESAN APP MIC	TET PARED NDRA F CKED NDRA F	20 BY ROONE BY A. FRY APPRO 96-0	21 E 1 EY	22 E 2	23 E	MIC HAI OV SIL	25 E 5 DI	26 E 6 CIRCINED,	E 7 SE SI COL	UPPL UMBI LINE DS, M	9 .Y CE US, O	NTEF HIO	ATIO	LUMB 6	us H	

1. SCOPE

- 1.1 <u>Scope</u>. This drawing documents three product assurance class levels consisting of high reliability (device classes Q and M), space application (device class V) and for appropriate satellite and similar applications (device class T). A choice of case outlines and lead finishes are available and are reflected in the Part or Identifying Number (PIN). When available, a choice of Radiation Hardness Assurance (RHA) levels are reflected in the PIN. For device class T, the user is encouraged to review the manufacturer's Quality Management (QM) plan as part of their evaluation of these parts and their acceptability in the intended application.
 - 1.2 PIN. The PIN is as shown in the following example:



- 1.2.1 <u>RHA designator</u>. Device classes Q, T and V RHA marked devices meet the MIL-PRF-38535 specified RHA levels and are marked with the appropriate RHA designator. Device class M RHA marked devices meet the MIL-PRF-38535, appendix A specified RHA levels and are marked with the appropriate RHA designator. A dash (-) indicates a non-RHA device.
 - 1.2.2 <u>Device type(s)</u>. The device type(s) identify the circuit function as follows:

Device type	<u>Generic number</u>	<u>Circuit function</u>
01	HS-508ARH	Radiation hardened DI CMOS single 8-
02	HS-508BRH	channel MUX with overvoltage protection Radiation hardened DI CMOS single 8-
		channel MUX with overvoltage protection

1.2.3 <u>Device class designator</u>. The device class designator is a single letter identifying the product assurance level as follows:

Device class	Device requirements documentation
M	Vendor self-certification to the requirements for MIL-STD-883 compliant, non-JAN class level B microcircuits in accordance with MIL-PRF-38535, appendix A
Q, V	Certification and qualification to MIL-PRF-38535
Т	Certification and qualification to MIL-PRF-38535 with performance as specified in the device manufacturers approved quality management plan.

1.2.4 <u>Case outline(s)</u>. The case outline(s) are as designated in MIL-STD-1835 and as follows:

Outline letter	Descriptive designator	<u>Terminals</u>	Package style
E	CDIP2-T16	16	Dual-in-line
X	CDFP4-F16	16	Flat pack

1.2.5 <u>Lead finish</u>. The lead finish is as specified in MIL-PRF-38535 for device classes Q, T and V or MIL-PRF-38535, appendix A for device class M.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 2

	STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
	07007	0175		<u> </u>
/ G	uaranteed by process or design, not tested.			
, -	Case outline X			
٧,	Case outline E	13.3 n	nW/°C	
	$_{\rm JA}$) at the following rates:		3. 22.2.0 miodily (tho dol	54554 511
	aximum levels may degrade performance and affect relia device power exceeds package dissipation capability, pro		ng or derate linearly (the der	ating is based on
	tresses above the absolute maximum rating may cause p		age to the device. Extended	operation at the
	•			
	Latch-up			
	Device type 01 Device type 02			'S
	Dose rate upset (20 ns pulse):		. 4 40 ⁸ D = 3/0°	/-
	Device type 01 and 02		100 Krad (Si)	
	Device type class T:		,	
	Device type 01			
	Device classes Q and V: Device type 01		100 Krad (Si)	
	Maximum total dose available (dose rate = 50 – 300 rads	s(Si)/s)		
	Device type 02		TBD	
	Device type 01		110 MEV/(cm ² / 1	mg) <u>3</u> /
	SEP effective let no upset:			
1.5	Radiation features			
	Ambient operating temperature range (T _A)			
	Logic high level (V _{AH})			
	Logic low level (V _{AL})			
	Operating supply voltage (±VSUPPLY)		±15 V	
1.4	Recommended operating conditions.			
	Junction temperature (T _J)		+175°C	
	Lead temperature (soldering, 10 seconds)			
	Case outline X			
	Case outline E			
	Thermal resistance, junction-to-ambient (θ_{JA}):			
	Case outline X		25°C/W	
	Case outline E			
	Thermal resistance, junction-to-case (θ_{JC}):			
	Case outline X		0.59 W	
	Case outline E		0.67 W	
	Maximum package power dissipation at $T_A = +125^{\circ}C$ (P _I			
	Storage temperature range	•		
	Peak current, S or D (pulsed at 1 ms, 10 percent duty cyc			
	-Vs			
	+Vs		+Vsiippi∨+20 V	1
	Analog input overvoltage:			
	-VEN, -VA		==::=:	
	+VEN, +VA		+Vcuppi v + 4 V	
	Supply voltage between -V and ground		20 V	
	Supply voltage between +V and ground		' 3U //	

2. APPLICABLE DOCUMENTS

2.1 <u>Government specification, standards, and handbooks</u>. The following specification, standards, and handbooks form a part of this drawing to the extent specified herein. Unless otherwise specified, the issues of these documents are those listed in the issue of the Department of Defense Index of Specifications and Standards (DoDISS) and supplement thereto, cited in the solicitation.

SPECIFICATION

DEPARTMENT OF DEFENSE

MIL-PRF-38535 - Integrated Circuits, Manufacturing, General Specification for.

STANDARDS

DEPARTMENT OF DEFENSE

MIL-STD-883 - Test Method Standard Microcircuits.

MIL-STD-973 - Configuration Management.

MIL-STD-1835 - Interface Standard For Microcircuit Case Outlines.

HANDBOOKS

DEPARTMENT OF DEFENSE

MIL-HDBK-103 - List of Standard Microcircuit Drawings (SMD's).

MIL-HDBK-780 - Standard Microcircuit Drawings.

(Unless otherwise indicated, copies of the specification, standards, and handbooks are available from the Standardization Document Order Desk, 700 Robbins Avenue, Building 4D, Philadelphia, PA 19111-5094.)

2.2 <u>Order of precedence</u>. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing takes precedence. Nothing in this document, however, supersedes applicable laws and regulations unless a specific exemption has been obtained.

3. REQUIREMENTS

- 3.1 <u>Item requirements</u>. The individual item requirements for device classes Q, T and V shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not affect the form, fit, or function as described herein. The individual item requirements for device class M shall be in accordance with MIL-PRF-38535, appendix A, as specified herein.
 - 3.1.1 Microcircuit die. For the requirements for microcircuit die, see appendix A to this document.
- 3.2 <u>Design, construction, and physical dimensions</u>. The design, construction, and physical dimensions shall be as specified in MIL-PRF-38535 and herein for device classes Q, T and V or MIL-PRF-38535, appendix A and herein for device class M.
 - 3.2.1 <u>Case outline(s)</u>. The case outline(s) shall be in accordance with 1.2.4 herein.
 - 3.2.2 <u>Terminal connection(s)</u>. The terminal connection(s) shall be as specified on figure 1.
 - 3.2.3 Truth table(s). The truth table(s) shall be as specified on figure 2.
 - 3.2.4 <u>Timing diagram(s)</u>. The timing diagram(s) shall be as specified on figure 3.
 - 3.2.5 Radiation exposure circuit. The radiation exposure circuit shall be as specified in table III.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 4

- 3.3 <u>Electrical performance characteristics and postirradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and postirradiation parameter limits are as specified in table I and shall apply over the full ambient operating temperature range.
- 3.4 <u>Electrical test requirements</u>. The electrical test requirements shall be the subgroups specified in table IIA. The electrical tests for each subgroup are defined in table I.
- 3.5 <u>Marking</u>. The part shall be marked with the PIN listed in 1.2 herein. In addition, the manufacturer's PIN may also be marked as listed in MIL-HDBK-103. For packages where marking of the entire SMD PIN number is not feasible due to space limitations, the manufacturer has the option of not marking the "5962-" on the device. For RHA product using this option, the RHA designator shall still be marked. Marking for device classes Q, T and V shall be in accordance with MIL-PRF-38535. Marking for device class M shall be in accordance with MIL-PRF-38535, appendix A.
- 3.5.1 <u>Certification/compliance mark</u>. The certification mark for device classes Q, T and V shall be a "QML" or "Q" as required in MIL-PRF-38535. The compliance mark for device class M shall be a "C" as required in MIL-PRF-38535, appendix A.
- 3.6 <u>Certificate of compliance</u>. For device classes Q, T and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 6.6.1 herein). For device class M, a certificate of compliance shall be required from a manufacturer in order to be listed as an approved source of supply in MIL-HDBK-103 (see 6.6.2 herein). The certificate of compliance submitted to DSCC-VA prior to listing as an approved source of supply for this drawing shall affirm that the manufacturer's product meets, for device classes Q, T and V, the requirements of MIL-PRF-38535 and herein or for device class M, the requirements of MIL-PRF-38535, appendix A and herein.
- 3.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device classes Q, T and V in MIL-PRF-38535 or for device class M in MIL-PRF-38535, appendix A shall be provided with each lot of microcircuits delivered to this drawing.
- 3.8 <u>Notification of change for device class M.</u> For device class M, notification to DSCC-VA of change of product (see 6.2 herein) involving devices acquired to this drawing is required for any change as defined in MIL-STD-973.
- 3.9 <u>Verification and review for device class M.</u> For device class M, DSCC, DSCC's agent, and the acquiring activity retain the option to review the manufacturer's facility and applicable required documentation. Offshore documentation shall be made available onshore at the option of the reviewer.
- 3.10 <u>Microcircuit group assignment for device class M.</u> Device class M devices covered by this drawing shall be in microcircuit group number 82 (see MIL-PRF-38535, appendix A).

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL	SHEET

TABLE I. <u>Electrical performance characteristics</u>.

Test	Symbol	Conditions $-55^{\circ}C \leq T_A \leq +125^{\circ}C$ $V_{AH} = +4 \text{ V, } V_{AL} = 0.8 \text{ V}$ $-V = -15 \text{ V, } +V = +15 \text{ V}$ unless otherwise specified	Group A subgroups	Device type	Limits		Unit
					Min	Max	
Input leakage current address, or enable pins	I _{AH}	Measure inputs sequentially, ground all unused pins	1, 2, 3	All -1000		+1000	nA
		M,D,P,L,R,F <u>1</u> /	1		-1000	+1000	1
Leakage current into the source terminal of	+IS(OFF)	V _S = +10 V, All unused inputs and outputs = -10 V,	1	All	-10	+10	nA
an "OFF" switch		V _{EN} = 0.8 V	2, 3		-50	+50	1
		M,D,P,L,R,F <u>1</u> /	1		-50	+50	1
	-Is(OFF)	V _S = -10 V, All unused inputs and outputs = +10 V	1	All	-10	+10	nA
		V _{EN} = 0.8 V	2, 3		-50	+50	1
		M,D,P,L,R,F <u>1</u> /	1		-50	+50	
Leakage current into the drain terminal of	+I _{D(OFF)}	V _D = +10 V, All unused inputs = -10 V,	1	All	-10	+10	nA
an "OFF" switch		V _{EN} = 0.8 V	2, 3		-250	+250	
		M,D,P,L,R,F <u>1</u> /	1		-250	+250	
	-I _{D(OFF)}	V _D = -10 V, All unused inputs and outputs = +10 V	1	All	-10	+10	nA
		V _{EN} = 0.8 V	2, 3		-250	+250	1
		M,D,P,L,R,F <u>1</u> /	1		-250	+250	1
Leakage current into the drain terminal of an "OFF" switch with overvoltage applied	+I _{D(OFF)} overvoltage	V _S = +25 V, Measure V _D , V _{EN} = 0.8 V, All unused inputs to GND	1, 2, 3	All	-2000	+2000	nA
		M,D,P,L,R,F <u>1</u> /	1		-2000	+2000	1

See footnotes at end of table.

	STANDARD
	MICROCIRCUIT DRAWING
С	DEFENSE SUPPLY CENTER COLUMBU

DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000

SIZE A		5962-96742
	REVISION LEVEL E	SHEET 6

TABLE I. <u>Electrical performance characteristics</u> - Continued.

		Con	ditions						
Test	Symbol	V _{AH} = +4 V, -V = -15 V, +		Group A subgroups	Device type	Liı	mits	Unit	
						Min	Max		
Leakage current into the drain terminal of an "OFF" switch with overvoltage applied	-I _{D(OFF)} overvoltage	$V_S = -25 \text{ V},$ $V_{EN} = 0.8 \text{ V}$ inputs to GN		1, 2, 3	All	-2000	+2000	nA	
		N	И,D,P,L,R,F <u>1</u> /	1		-2000	+2000		
Leakage current from an "ON" driver into the switch (drain and	+I _D (ON)	V _S = V _D = + V _{EN} = 4.0 V		1	All	-10	+10	nA	
source)		inputs = -10	V	2, 3		-250	+250		
			И,D,P,L,R,F <u>1</u> /	1		-250	+250	1	
	-I _{D(ON)}	V _S = V _D = - ⁻¹ V _{EN} = 4.0 V		1	All	-10	+10	nA	
			inputs = +10		2, 3		-250	+250	-
			И,D,P,L,R,F <u>1</u> /	1		-250	+250	1	
Switch on resistance	+R _(ON)	V _S = +10 V,	V _{EN} = 4.0 V,	1	All		1500	Ω	
		I _{OUT} = -100 μA		2, 3			1800		
			И,D,P,L,R,F <u>1</u> /	1			1800		
	-R _(ON)	V _S = -10 V,	V _{EN} = 4.0 V,	1	All		1500	Ω	
		I _{OUT} = +100	μΑ						
				2, 3			1800		
			И,D,P,L,R,F <u>1</u> /	1			1800		
Positive supply current	l(+)	V _{EN} = 4.0 V		1, 2, 3	All		2	mA	
		N	//,D,P,L,R,F <u>1</u> /	1			2]	
Negative supply current	l(-)	V _{EN} = 4.0 V		1, 2, 3	All	-1		mA	
		\ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \ \	И,D,P,L,R,F <u>1</u> /	1		-1		1	

See footnotes at end of table.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 7

TABLE I. <u>Electrical performance characteristics</u> - Continued.

			Conditions					I	
Test	Symbol	-55°C \leq T _A \leq +125°C V _{AH} = +4 V, V _{AL} = 0.8 V -V = -15 V, +V = +15 V unless otherwise specified		Group A subgroups	Device type	Limits		Unit	
						Min	Max		
Positive standby supply current	+l(SBY)	V _{EN} = 0.8		1, 2, 3	All		2	mA	
			M,D,P,L,R,F <u>1</u> /	1			2		
Negative standby supply current	-I(SBY)	V _{EN} = 0.8	3 V	1, 2, 3	All	-1		mA	
,			M,D,P,L,R,F <u>1</u> /	1		-1			
Capacitance address input	C _A <u>2</u> /	+V _S = -V _S f = 1 MHz		4	All		7	pF	
Capacitance channel input	C _{S(OFF)} 2/	+Vs = -Vs f = 1 MHz	-	4	All		7	pF	
Capacitance channel output	C _{D(OFF)} 2/	+V _S = -V _S f = 1 MHz		4	All		25	pF	
Off isolation	V _{ISO} <u>2</u> / <u>3</u> /		3 V, f = 200 kHz, F , R_L = 1 k Ω , V RMS	4	All	45		dB	
Analog signal range	VS	See 4.4.1	b	7, 8	All	-15	+15	V	
Break-before-make time delay	T _D	R _L = 1000 See figure	0 Ω, C _L = 50 pF e 3	9	All	25		ns	
				10, 11		5			
			M,D,P,L,R,F <u>1</u> /	9	1	5		1	
Access time: Address inputs to I/O channels	T _{ON(A)}	R _L = 10 k See figure	Ω , $C_L = 50 \text{ pF}$ e 3	9	All		600	ns	
	. '			10, 11	1		1000	1	
			M,D,P,L,R,F <u>1</u> /	9	†		3000	1	

See footnotes at end of table.

STANDARD MICROCIRCUIT DRAWING	SIZE A	
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E

5962-96742

8

SHEET

TABLE I. Electrical performance characteristics - Continued.

Test	Symbol	Conditions $ -55^{\circ}C \leq T_{A} \leq +125^{\circ}C $ $V_{AH} = +4 \text{ V, } V_{AL} = 0.8 \text{ V} $ $-V = -15 \text{ V, } +V = +15 \text{ V} $ unless otherwise specified		Group A subgroups	Device type	Limits		Unit	
						Min	Max		
Access time: Enable to I/O	T _{ON(EN)} T _{OFF(EN)}	R _L = 1000 See figure	0 Ω, C _L = 50 pF e 3	9	All		600	ns	
				10, 11			1000		
			M,D,P,L,R,F <u>1</u> /	9			3000		

- 1/ Devices supplied to this drawing will meet all levels M, D, P, L, and R, for device type 01 (device classes Q and V) and levels M, D, P, L, R, F, for device type 02 (devices classes Q or V) and levels M, D, P, L, R, for device types 01 and 02 (device class T). However, device type 01 (device classes Q and V) is only tested at the "R" level and device type 02 (device classes Q and V) is only tested at the "F" level, and device types 01 and 02 (class T) is only tested at the "R" level. (see paragraph 1.5 herein). Pre and Post irradiation values are identical unless otherwise specified in Table I. When performing post irradiation electrical measurements for any RHA level, TA = +25°C.
- 2/ These parameters are controlled via design or process parameters and not directly tested. These parameters are characterized upon initial design changes which would affect these characteristics. See 4.4.1d.
- 3/ Worst case isolation occurs on channel 4 due to proximity of the output pins.

4. QUALITY ASSURANCE PROVISIONS

4.1 <u>Sampling and inspection</u>. For device classes Q and V, sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's QM plan, including screening (4.2), qualification (4.3), and conformance inspection (4.4). The modification in the QM plan shall not affect the form, fit, or function as described herein.

For device class T, sampling and inspection procedures shall be in accordance with MIL-PRF-38535 and the device manufacturer's QM plan, including screening, qualification, and conformance inspection. The performance envelope and reliability information shall be as specified in the manufacturer's QM plan.

For device class M, sampling and inspection procedures shall be in accordance with MIL-PRF-38535, appendix A.

4.2 <u>Screening</u>. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and shall be conducted on all devices prior to qualification and technology conformance inspection. For device class M, screening shall be in accordance with method 5004 of MIL-STD-883, and shall be conducted on all devices prior to quality conformance inspection. For device class T, screening shall be in accordance with the device manufacturer's Quality Management (QM) plan, and shall be conducted on all devices prior to qualification and technology conformance inspection.

STANDARD						
MICROCIRCUIT DRAWING						
DEFENSE SUPPLY CENTER COLUMBU						

DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000

SIZE A		5962-96742
	REVISION LEVEL E	SHEET 9

Device types	01 and 02
Case outlines	E and X
Terminal number	Terminal symbol
1	A0
2	EN
3	-V
4	IN 1
5	IN 2
6	IN 3
7	IN 4
8	OUT
9	IN 8
10	IN 7
11	IN 6
12	IN 5
13	+V
14	GND
15	A2
16	A1

FIGURE 1. Terminal connections.

A2	A1	A0	EN	"ON" CHANNEL
X	Х	X	L	NONE
L	L	L	Н	1
L	L	Н	Н	2
L	Н	Ш	Н	3
L	Н	Н	Н	4
Н	L	Ш	Н	5
Н	L	Н	Н	6
Н	Н	L	Н	7
Н	Н	Н	Н	8

FIGURE 2. Truth table.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 10

BREAK-BEFORE-MAKE DELAY(t_D) A2 IN 1 IN 2 A1 THRU A0 IN 7 IN 8 EN OUT GND VAH = 4.0 V ADDRESS DRIVE (V_A)

- OUTPUT

FIGURE 3. Timing diagrams.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 11

ACCESS TIME (t_A) A2 IN 1 A1 IN 2 A0 IN 7 A0 IN 8 EN OUT GND VAH = 4.0 V

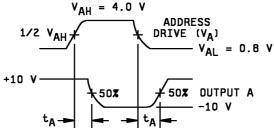
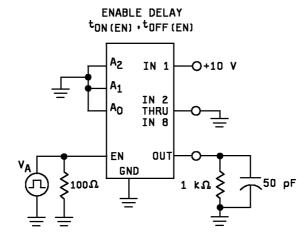


FIGURE 3. Timing diagrams - Continued.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 12



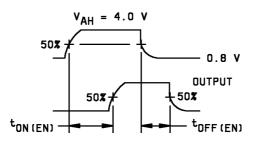


FIGURE 3. <u>Timing diagrams</u> - Continued.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 13

4.2.1 Additional criteria for device class M.

- a. Burn-in test, method 1015 of MIL-STD-883.
 - (1) Test condition A, B, C or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015.
 - (2) $T_A = +125^{\circ}C$, minimum.
- b. Interim and final electrical test parameters shall be as specified in table IIA herein.

4.2.2 Additional criteria for device classes Q, T and V.

- a. The burn-in test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The burn-in test circuit shall be maintained under document revision level control of the device manufacturer's Technology Review Board (TRB) in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1015 of MIL-STD-883.
- b. Interim and final electrical test parameters shall be as specified in table IIA herein.
- c. Additional screening for device class V beyond the requirements of device class Q shall be as specified in MIL-PRF-38535, appendix B or as modified in the device manufacturer's Quality Management (QM) plan.
- 4.3 <u>Qualification inspection for device classes Q, T and V.</u> Qualification inspection for device classes Q and V shall be in accordance with MIL-PRF-38535. Qualification inspection for device class T shall be in accordance with the device manufacturer's Quality Management (QM) plan. Inspections to be performed shall be those specified in MIL-PRF-38535 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4).
- 4.4 <u>Conformance inspection</u>. Technology conformance inspection for classes Q and V shall be in accordance with MIL-PRF-38535, or as specified in the QM plan, including groups A, B, C, D, and E inspections and as specified herein except where option 2 of MIL-PRF-38535 permits alternate in-line control testing. Quality conformance inspection for device class M shall be in accordance with MIL-PRF-38535, appendix A and as specified herein. Inspections to be performed for device class M shall be those specified in method 5005 of MIL-STD-883 and herein for groups A, B, C, D, and E inspections (see 4.4.1 through 4.4.4). Technology conformance inspection for class T shall be in accordance with the device manufacturer's Quality Management (QM) plan.

4.4.1 Group A inspection.

- a. Tests shall be as specified in table IIA herein.
- b. For device class M, subgroups 7 and 8 tests shall be sufficient to verify the truth table. For device classes Q and V, subgroups 7 and 8 shall include verifying the functionality of the device.
- c. Subgroups 5 and 6 in table I, method 5005 of MIL-STD-883 shall be omitted.
- d. Subgroup 4 (CA, CS(OFF), CD(OFF), and VISO measurements) should be measured only for initial qualification and after any process or design changes which may affect input, output capacitance or isolation voltage.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 14

TABLE IIA. Electrical test requirements.

Test requirements	Subgroups (in accordance with MIL-STD-883, method 5005, table I)	Subgroups (in accordance with MIL-PRF-38535, table III)		
	Device class M	Device class Q	Device class V	Device class T
Interim electrical parameters (see 4.2)	1, 7, 9	1, 7, 9	1, 7, 9	As specified in QM plan
Final electrical parameters (see 4.2)	1,2,3,7,8,9, 10,11 <u>1</u> /	1,2,3,7,8,9, 10,11 <u>1</u> /	1,2,3,7,8,9, 10,11 <u>1</u> / <u>2</u> /	
Group A test requirements (see 4.4)	1,2,3,4,7,8, 9,10,11 <u>3</u> /	1,2,3,4,7,8, 9,10,11 <u>3</u> /	1,2,3,4,7,8, 9,10,11 <u>3</u> /	
Group C end-point electrical parameters (see 4.4)	1,2,3,7,8,9, 10,11	1,2,3,7,8,9, 10,11	1,2,3,7,8,9, 10,11 <u>2</u> /	
Group D end-point electrical parameters (see 4.4)	1, 7, 9	1, 7, 9	1, 7, 9	
Group E end-point electrical parameters (see 4.4)	1, 7, 9	1, 7, 9	1, 7, 9	

- <u>1</u>/ PDA applies to subgroup 1 and 7. For class V to subgroups 1, 7 and Δ .
- 2/ Delta limits (see table IIB) shall be required and the delta values shall be computed with reference to the zero hour electrical parameters (see table I).
- 3/ Subgroup 4, if not tested, shall be guaranteed to the limits specified in table I.
- 4.4.2 Group C inspection. The group C inspection end-point electrical parameters shall be as specified in table IIA herein.
- 4.4.2.1 Additional criteria for device class M. Steady-state life test conditions, method 1005 of MIL-STD-883:
 - a. Test condition A, B, C, or D. The test circuit shall be maintained by the manufacturer under document revision level control and shall be made available to the preparing or acquiring activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.
 - b. $T_A = +125$ °C, minimum.
 - c. Test duration: 1,000 hours, except as permitted by method 1005 of MIL-STD-883.
- 4.4.2.2 Additional criteria for device classes Q, T and V. The steady-state life test duration, test condition and test temperature, or approved alternatives shall be as specified in the device manufacturer's QM plan in accordance with MIL-PRF-38535. The test circuit shall be maintained under document revision level control by the device manufacturer's TRB in accordance with MIL-PRF-38535 and shall be made available to the acquiring or preparing activity upon request. The test circuit shall specify the inputs, outputs, biases, and power dissipation, as applicable, in accordance with the intent specified in test method 1005 of MIL-STD-883.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 15

TABLE IIB. Burn-in delta parameters (+25°C).

Parameters	Symbol	Conditions	Delta limits
Input leakage current, Address or Enable pins	I _{AH}	Measure inputs sequentially, Ground all unused pins	±100 nA
	I _{AL}		
Leakage current into the source terminal of an "OFF" switch	+Is(OFF)	$V_S = +10 \text{ V}$, All unused inputs and outputs = -10 V, $V_{EN} = 0.8 \text{ V}$	±20 nA
	-IS(OFF)	V _S = -10 V, All unused inputs and outputs = +10 V, V _{EN} = 0.8 V	±20 nA
Leakage current into the drain terminal of an "OFF" switch	+I _{D(OFF)}	$V_D = +10 \text{ V}, V_{EN} = 0.8 \text{ V},$ All unused inputs = -10 V	±20 nA
	-I _{D(OFF)}	$V_D = -10 \text{ V}, V_{EN} = 0.8 \text{ V},$ All unused inputs = +10 V	±20 nA
Leakage current from an "ON" driver into the switch (drain & source)	+ID(ON)	$V_S = V_D = +10 \text{ V},$ $V_{EN} = 4.0 \text{ V},$ All unused inputs = -10 V	±20 nA
	-I _{D(ON)}	$V_S = V_D = -10 \text{ V},$ $V_{EN} = 4.0 \text{ V},$ All unused inputs = +10 V	±20 nA
Switch ON resistance	+R _(ON)	V _S = +10 V, V _{EN} = 4.0 V, I _{OUT} = -100 μA	±150 Ω
	-R _(ON)	$V_S = -10 \text{ V}, V_{EN} = 4.0 \text{ V},$ $I_{OUT} = +100 \mu\text{A}$	±150 Ω
Positive supply current	l(+)	V _{EN} = 4.0 V	±200 μA
Negative supply current	l(-)	V _{EN} = 4.0 V	±100 μA
Positive standby supply current	+l(SBY)	V _{EN} = 0.8 V	±200 μA
Negative standby supply current	-I(SBY)	V _{EN} = 0.8 V	±100 μA

TABLE III. Irradiation test connections. $(T_A = +25^{\circ}C \pm 5^{\circ}C)$

Ground	+15 V ± 5%	-15 V ± 5%	NC
1,2,4,5,6,7,9,10,11, 12,14,15,16	13	3	8

 $\underline{1}/$ Pins 3 and 13 each have a series resistor (Rs) = 1 k Ω ±5%.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 16

- 4.4.3 Group D inspection. The group D inspection end-point electrical parameters shall be as specified in table IIA herein.
- 4.4.4 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be marked as radiation hardness assured (see 3.5 herein). RHA levels for device classes M, Q and V shall be as specified in MIL-PRF-38535 and the end-point electrical parameters shall be as specified in table IIA herein. For device class T, the RHA requirements shall be in accordance with the Class T Radiation Requirements of MIL-PRF-38535. The end-point electrical parameters for class T devices shall be as specified in Table I, Group A subgroups, or as modified in the QM plan.
- 4.4.4.1 <u>Total dose irradiation testing</u>. Total dose irradiation testing shall be performed in accordance with MIL-STD-883 method 1019 condition A and as specified herein. For device class T, the total dose requirements shall be in accordance with the class T radiation requirements of MIL-PRF-38535 (see 1.5 herein).
- 4.4.4.1.1 <u>Accelerated aging test</u>. Accelerated aging tests shall be performed on all devices requiring a RHA level greater than 5k rads(Si). The post-anneal end-point electrical parameter limits shall be as specified in table I herein and shall be the pre-irradiation end-point electrical parameter limit at 25°C. Testing shall be performed at initial qualification and after any design or process changes which may affect the RHA response of the device.
- 4.4.4.2 <u>Dose rate induced latchup testing</u>. Dose rate induced latchup testing shall be performed in accordance with test method 1020 of MIL-STD-883 and as specified herein (see 1.5 herein). Tests shall be performed on devices, SEC, or approved test structures at technology qualification and after any design or process changes which may effect the RHA capability of the process.
- 4.4.4.3 <u>Dose rate upset testing</u>. Dose rate upset testing shall be performed on a technology process, in accordance with test method 1023 of MIL-STD-883 and herein (see 1.5 herein).
 - a. Transient dose rate upset testing shall be performed at initial qualification and after any design or process changes which may effect the RHA performance of the device. Test 10 devices with 0 defects unless otherwise specified.
 - b. Transient dose rate upset testing for class Q, T, and V devices shall be performed as specified by a TRB approved radiation hardness assurance plan and MIL-PRF-38535.
- 4.4.4.4 <u>Dose rate burnout</u>. When required by the customer, test shall be performed on devices, SEC, or approved test structures at technology qualifications and after any design or process changes which may effect the RHA capability of the process. Dose rate burnout shall be performed in accordance with test method 1023 of MIL-STD-883 and as specified herein.
- 4.4.4.5 <u>Single event phenomena (SEP)</u>. When specified in the purchase order or contract SEP testing shall be required on class T and V devices (see 1.5 herein). SEP testing shall be performed on a technology process on the Standard Evaluation Circuit (SEC) or alternate SEP test vehicle as approved by the qualifying activity at initial qualification and after any design or process changes which may affect the upset or latchup characteristics. The recommended test conditions for SEP are as follows:
 - a. The ion beam angle of incidence shall be between normal to the die surface and 60° to the normal, inclusive (i.e. $0^{\circ} \le \text{angle} \le 60^{\circ}$). No shadowing of the ion beam due to fixturing or package related effects is allowed.
 - b. The fluence shall be ≥ 100 errors or $\geq 10^6$ ions/cm².
 - c. The flux shall be between 10² and 10⁵ ions/cm²/s. The cross-section shall be verified to be flux independent by measuring the cross-section at two flux rates which differ by at least an order of magnitude.
 - d. The particle range shall be \geq 20 microns in silicon.
 - e. The test temperature shall be +25°C and the maximum rated operating temperature ±10°C.
 - f. Bias conditions shall be defined by the manufacturer for latchup measurements.
 - g. Test four devices with zero failures.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 17

5. PACKAGING

5.1 <u>Packaging requirements</u>. The requirements for packaging shall be in accordance with MIL-PRF-38535 for device classes Q, T and V or MIL-PRF-38535, appendix A for device class M.

6. NOTES

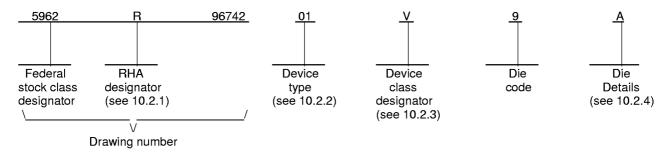
- 6.1 <u>Intended use</u>. Microcircuits conforming to this drawing are intended for use for Government microcircuit applications (original equipment), design applications, and logistics purposes.
- 6.1.1 Replaceability. Microcircuits covered by this drawing will replace the same generic device covered by a contractor prepared specification or drawing.
 - 6.1.2 <u>Substitutability</u>. Device class Q devices will replace device class M devices.
- 6.2 <u>Configuration control of SMD's</u>. All proposed changes to existing SMD's will be coordinated with the users of record for the individual documents. This coordination will be accomplished in accordance with MIL-STD-973 using DD Form 1692, Engineering Change Proposal.
- 6.3 <u>Record of users</u>. Military and industrial users should inform Defense Supply Center Columbus when a system application requires configuration control and which SMD's are applicable to that system. DSCC will maintain a record of users and this list will be used for coordination and distribution of changes to the drawings. Users of drawings covering microelectronic devices (FSC 5962) should contact DSCC-VA, telephone (614) 692-0525.
- 6.4 <u>Comments</u>. Comments on this drawing should be directed to DSCC-VA, Columbus, Ohio 43216-5000, or telephone (614) 692-0674.
- 6.5 <u>Abbreviations, symbols, and definitions</u>. The abbreviations, symbols, and definitions used herein are defined in MIL-PRF-38535 and MIL-HDBK-1331.
 - 6.6 Sources of supply.
- 6.6.1 <u>Sources of supply for device classes Q, T and V</u>. Sources of supply for device classes Q, T and V are listed in QML-38535. The vendors listed in QML-38535 have submitted a certificate of compliance (see 3.6 herein) to DSCC-VA and have agreed to this drawing.
- 6.6.2 <u>Approved sources of supply for device class M.</u> Approved sources of supply for class M are listed in MIL-HDBK-103. The vendors listed in MIL-HDBK-103 have agreed to this drawing and a certificate of compliance (see 3.6 herein) has been submitted to and accepted by DSCC-VA.
- 6.7 <u>Additional information</u>. When applicable, a copy of the following additional data shall be maintained and available from the device manufacturer:
 - a. RHA upset levels.
 - b. Test conditions (SEP).
 - c. Number of upsets (SEP).
 - d. Number of transients (SEP).
 - e. Occurrence of latchup (SEP).

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 18

10. SCOPE

10.1 <u>Scope</u>. This appendix establishes minimum requirements for microcircuit die to be supplied under the Qualified Manufacturers List (QML) Program. QML microcircuit die meeting the requirements of MIL-PRF-38535 and the manufacturers approved QML plan for use in monolithic microcircuits, multi-chip modules (MCMs), hybrids, electronic modules, or devices using chip and wire designs in accordance with MIL-PRF-38534 are specified herein. Two product assurance classes consisting of military high reliability (device class Q) and space application (device Class V) are reflected in the Part or Identification Number (PIN). When available a choice of Radiation Hardness Assurance (RHA) levels are reflected in the PIN.

10.2 PIN. The PIN is as shown in the following example:



10.2.1 RHA designator. Device classes Q and V RHA identified die shall meet the MIL-PRF-38535 specified RHA levels. A dash (-) indicates a non-RHA die.

10.2.2 <u>Device type(s)</u>. The device type(s) shall identify the circuit function as follows:

Device type	Generic number	Circuit function
01	HS-508ARH	Radiation hardened, DI, CMOS single 8-channel MUX with overvoltage protection.
02	HS-508BRH	Radiation hardened, DI, CMOS single 8-channel MUX with overvoltage protection.

10.2.3 Device class designator.

Device class

Device requirements documentation

Q or V

Certification and qualification to the die requirements of MIL-PRF-38535

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS		REVISION LEVEL	SHEET
COLUMBUS, OHIO 43216-5000		E	19

10.2.4. <u>Die Details</u>. The die details designation shall be a unique letter which designates the die's physical dimensions, bonding pad location(s) and related electrical function(s), interface materials, and other assembly related information, for each product and variant supplied to this appendix.

10.2.4.1 Die physical dimensions.

Die type Figure number

01 A-1
02 A-2

10.2.4.2. Die bonding pad locations and electrical functions.

Die type Figure number

01 A-1
02 A-2

10.2.4.3. Interface materials.

Die type Figure number

01 A-1
02 A-2

10.2.4.4. Assembly related information.

Die type Figure number

01 A-1
02 A-2

- 10.3. Absolute maximum ratings. See paragraph 1.3 within the body of this drawing for details.
- 10.4 Recommended operating conditions. See paragraph 1.4 within the body of this drawing for details.

STANDARD MICROCIRCUIT DRAWING	SIZE A	
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL

5962-96742

20

SHEET

20. APPLICABLE DOCUMENTS.

20.1 <u>Government specifications, standards, and handbooks</u>. Unless otherwise specified, the following specification, standard, and handbook of the issue listed in that issue of the Department of Defense Index of Specifications and Standards specified in the solicitation, form a part of this drawing to the extent specified herein.

SPECIFICATION

DEPARTMENT OF DEFENSE

MIL-PRF-38535 - Integrated Circuits, Manufacturing, General Specification for.

STANDARDS

DEPARTMENT OF DEFENSE

MIL-STD-883 - Test Method Standard Microcircuits.

HANDBOOK

DEPARTMENT OF DEFENSE

MIL-HDBK-103 - List of Standard Microcircuit Drawings (SMD's).

(Copies of the specification, standard, and handbook required by manufacturers in connection with specific acquisition functions should be obtained from the contracting activity or as directed by the contracting activity).

20.2. Order of precedence. In the event of a conflict between the text of this drawing and the references cited herein, the text of this drawing shall take precedence.

30. REQUIREMENTS

- 30.1 <u>Item requirements</u>. The individual item requirements for device classes Q and V shall be in accordance with MIL-PRF-38535 and as specified herein or as modified in the device manufacturer's Quality Management (QM) plan. The modification in the QM plan shall not effect the form, fit or function as described herein.
- 30.2 <u>Design, construction and physical dimensions</u>. The design, construction and physical dimensions shall be as specified in MIL-PRF-38535 and the manufacturer's QM plan, for device classes Q and V and herein.
- 30.2.1 <u>Die physical dimensions</u>. The die physical dimensions shall be as specified in 10.2.4.1 and on figure A-1 (device type 01) or figure A-2 (device type 02).
- 30.2.2 <u>Die bonding pad locations and electrical functions</u>. The die bonding pad locations and electrical functions shall be as specified in 10.2.4.2 and on figure A-1 (device type 01) or figure A-2 (device type 02).
- 30.2.3 Interface materials. The interface materials for the die shall be as specified in 10.2.4.3 and on figure A-1 (device type 01) or figure A-2 (device type 02).
- 30.2.4 <u>Assembly related information</u>. The assembly related information shall be as specified in 10.2.4.4 and figure A-1 (device type 01) or figure A-2 (device type 02).
 - 30.2.5 Truth table(s). The truth table(s) shall be as defined within paragraph 3.2.3. of the body of this document.
- 30.2.6 Radiation exposure circuit. The radiation exposure circuit shall be as defined within paragraph 3.2.5. of the body of this document.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 21

- 30.3 <u>Electrical performance characteristics and post-irradiation parameter limits</u>. Unless otherwise specified herein, the electrical performance characteristics and post-irradiation parameter limits are as specified in table I of the body of this document.
- 30.4 <u>Electrical test requirements</u>. The wafer probe test requirements shall include functional and parametric testing sufficient to make the packaged die capable of meeting the electrical performance requirements in table I.
- 30.5 <u>Marking</u>. As a minimum, each unique lot of die, loaded in single or multiple stack of carriers, for shipment to a customer, shall be identified with the wafer lot number, the certification mark, the manufacturer's identification and the PIN listed in 10.2 herein. The certification mark shall be a "QML" or "Q" as required by MIL-PRF-38535.
- 30.6 <u>Certification of compliance</u>. For device classes Q and V, a certificate of compliance shall be required from a QML-38535 listed manufacturer in order to supply to the requirements of this drawing (see 60.4 herein). The certificate of compliance submitted to DSCC-VA prior to listing as an approved source of supply for this appendix shall affirm that the manufacturer's product meets, for device classes Q and V, the requirements of MIL-PRF-38535 and the requirements herein.
- 30.7 <u>Certificate of conformance</u>. A certificate of conformance as required for device classes Q and V in MIL-PRF-38535 shall be provided with each lot of microcircuit die delivered to this drawing.

40. QUALITY ASSURANCE PROVISIONS

- 40.1 <u>Sampling and inspection</u>. For device classes Q and V, die sampling and inspection procedures shall be in accordance with MIL-PRF-38535 or as modified in the device manufacturer's Quality Management (QM) plan. The modifications in the QM plan shall not effect the form, fit or function as described herein.
- 40.2 <u>Screening</u>. For device classes Q and V, screening shall be in accordance with MIL-PRF-38535, and as defined in the manufacturer's QM plan. As a minimum it shall consist of:
 - a) Wafer lot acceptance for Class V product using the criteria defined within MIL-STD-883 test method 5007.
 - b) 100% wafer probe (see paragraph 30.4).
 - 100% internal visual inspection to the applicable class Q or V criteria defined within MIL-STD-883 test method 2010 or the alternate procedures allowed within MIL-STD-883 test method 5004.

40.3 Conformance inspection.

40.3.1 <u>Group E inspection</u>. Group E inspection is required only for parts intended to be identified as radiation assured (see 30.5 herein). RHA levels for device classes Q and V shall be as specified in MIL-PRF-38535. End point electrical testing of packaged die shall be as specified in table IIA herein. Group E tests and conditions are as specified within paragraphs 4.4.4.1, 4.4.4.3, 4.4.4.4, and 4.4.4.5.

50. DIE CARRIER

50.1 <u>Die carrier requirements</u>. The requirements for the die carrier shall be in accordance with the manufacturer's QM plan or as specified in the purchase order by the acquiring activity. The die carrier shall provide adequate physical, mechanical and electrostatic protection.

STANDARD MICROCIRCUIT DRAWING DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000	SIZE A		5962-96742
		REVISION LEVEL E	SHEET 22

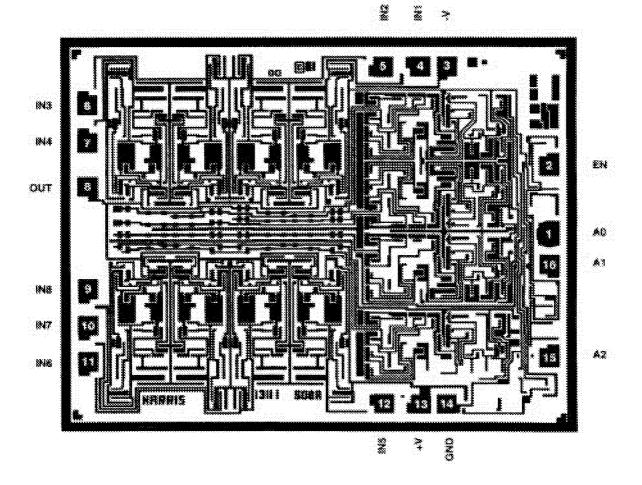
60 NOTES

- 60.1 <u>Intended use</u>. Microcircuit die conforming to this drawing are intended for use in microcircuits built in accordance with MIL-PRF-38535 or MIL-PRF-38534 for government microcircuit applications (original equipment), design applications and logistics purposes.
- 60.2 <u>Comments</u>. Comments on this appendix should be directed to DSCC-VA, Columbus, Ohio, 43216-5000 or telephone (614)-692-0536.
- 60.3 <u>Abbreviations, symbols and definitions</u>. The abbreviations, symbols, and definitions used herein are defined within MIL-PRF-38535 and MIL-STD-1331.
- 60.4 <u>Sources of supply for device classes Q and V</u>. Sources of supply for device classes Q and V are listed in QML-38535. The vendors listed within QML-38535 have submitted a certificate of compliance (see 30.6 herein) to DSCC-VA and have agreed to this drawing.

STANDARD		
MICROCIRCUIT DRAWING		
DEFENDE OURDLY OFNITED COLUMN		

DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000

SIZE A		5962-96742
	REVISION LEVEL E	SHEET 23



NOTE: Pad numbers reflect terminal numbers when placed in case outlines E and X (see Figure 1) for device type 01.

FIGURE A-1. Die bonding pad locations and electrical functions.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 24

Device type 01

Die physical dimensions.

Die size: 2120 x 2750 microns Die thickness: 19 ± 1 mils

Interface materials.

Top metallization: Al/Cu 12.5 kÅ \pm 2 kÅ Backside metallization: None.

Glassivation. Type: SiO₂

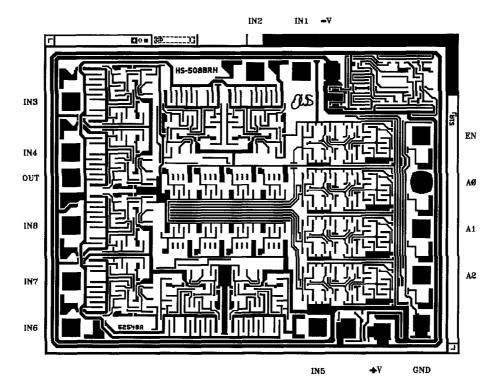
Thickness: 8 kÅ ± 1 kÅ

Substrate: Dielectrically Isolated (DI)

Assembly related information.
Substrate potential: Insulator
Special assembly instructions: None

FIGURE A-1. Die bonding pad locations and electrical functions - continued.

STANDARD MICROCIRCUIT DRAWING DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000 SIZE A 5962-96742 REVISION LEVEL E 25



NOTE: Pad numbers reflect terminal numbers when placed in case outlines E and X (see Figure 1) for device type 02.

FIGURE A-2. Die bonding pad locations and electrical functions.

STANDARD MICROCIRCUIT DRAWING	SIZE A		5962-96742
DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000		REVISION LEVEL E	SHEET 26

Device type 02

Die physical dimensions.

Die size: 3050×2360 microns Die thickness: 19 ± 1 mils

Interface materials.

Top metallization: Al/Si/Cu 16.0 kÅ \pm 2 kÅ

Backside metallization: None.

Glassivation. Type: PSG

Thickness: 8 kÅ ± 1 kÅ

Substrate: Dielectrically Isolated (DI)

Assembly related information. Substrate potential: Insulator

Special assembly instructions: None

FIGURE A-2. Die bonding pad locations and electrical functions - continued.

STANDARD MICROCIRCUIT DRAWING DEFENSE SUPPLY CENTER COLUMBUS COLUMBUS, OHIO 43216-5000 SIZE A 5962-96742 REVISION LEVEL E 27

STANDARD MICROCIRCUIT DRAWING BULLETIN

DATE: 00-01-03

Approved sources of supply for SMD 5962-96742 are listed below for immediate acquisition information only and shall be added to MIL-HDBK-103 and QML-38535 during the next revision. MIL-HDBK-103 and QML-38535 will be revised to include the addition or deletion of sources. The vendors listed below have agreed to this drawing and a certificate of compliance has been submitted to and accepted by DSCC-VA. This bulletin is superseded by the next dated revision of MIL-HDBK-103 and QML-38535.

Standard microcircuit drawing PIN <u>1</u> /	Vendor CAGE number	Vendor similar PIN <u>2</u> /
5962R9674201QEC	34371	HS1-508ARH-8
5962F9674202QEC	34371	HS1-508BRH-8
5962R9674201QXC	34371	HS9-508ARH-8
5962F9674202QXC	34371	HS9-508BRH-8
5962R9674201VEC	34371	HS1-508ARH-Q
5962F9674202VEC	34371	HS1-508BRH-Q
5962R9674201VXC	34371	HS9-508ARH-Q
5962F9674202VXC	34371	HS9-508BRH-Q
5962R9674201TEC	34371	HS1-508ARH-T
5962R9674202TEC	34371	HS1-508BRH-T
5962R9674201TXC	34371	HS9-508ARH-T
5962R9674202TXC	34371	HS9-508BRH-T

STANDARD MICROCIRCUIT DRAWING BULLETIN - CONTINUED.

Standard microcircuit drawing PIN <u>1</u> /	Vendor CAGE number	Vendor similar PIN <u>2</u> /
5962R9674201V9A	34371	HS0-508ARH-Q
5962F9674202V9A	34371	HS0-508BRH-Q

- 1/ The lead finish shown for each PIN representing a hermetic package is the most readily available from the manufacturer listed for that part. If the desired lead finish is not listed contact the vendor to determine its availability.
- <u>2</u>/ <u>Caution</u>. Do not use this number for item acquisition. Items acquired to this number may not satisfy the performance requirements of this drawing.

Vendor CAGE number

34371

Vendor name and address

Intersil Corporation P.O. Box 883 Melbourne, FL 32902-0883

The information contained herein is disseminated for convenience only and the Government assumes no liability whatsoever for any inaccuracies in the information bulletin.